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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

	Complete if Known	
Application Number	10/027,951	
Filing Date	December 19, 2001	
First Named Inventor	Donald L. Yates	
Group Art Unit	1746	
Examiner Name	Unknown	
Attorney Docket Number	3375.6US (95-0999.5)	

Examiner Cite Initials * No.1	Document Number		Name of Patentee or Applicant of		
	Number - Kind Code <sup>1</sup> (if known)	Publication Date MM-DD-YYYY	Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
114		US-5,371,950	12/13/1994	Schumacher	
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<sup>&</sup>lt;sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at <a href="https://www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.





Form PTO-1449

## INFORMATION DISCLOSURE CITATION IN AN APPLICATION

Docket Number (Optional) 3375.6US (95-0999.4)

Application Number Not yet assigned

Applicant Donald L. Yat s

## (Use several sheets if necessary) Filing Date December 19, 2001 Group Art Unit Unknown **U.S. PATENT DOCUMENTS** EXAMINER INITIAL DOCUMENT NUMBER FILING DATE IF APPROPRIATE DATE NAME CLASS SUBCLASS 4,132,567 01/1979 Blackwood 4,197,000 04/1980 Blackwood 4,286,541 09/1981 Blackwood 4,635,666 01/1987 Daley et al. 4,682,615 07/1987 Burkman et al. 4,911,761 03/1990 McConnell et al. 4,984,597 01/1991 McConnell et al. 4,997,490 03/1991 Vetter et al. 5,069,235 12/1991 Vetter et al. 5,095,927 03/1992 Thompson et al. 5,115,576 05/1992 Roberson, Jr. et al. FOREIGN PATENT DOCUMENTS Translation DOÇUMENT DATE COUNTRY CLASS SUBCLASS NUMBER 0,385,536 05/1990 EΡ 61-154130 07/1986 Japan 4-99025 03/1992 Japan 4-152525 05/1992 Japan 4-253332 09/1992 Japan OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Handbook of Semiconductor Wafer Cleaning Technology, editor W. Kern, Noyes Publications, pp. 131-51 and 405-15. Koppenbrink et al., Particle Reduction on Silicon Wafers as a Result of Isopropyl Alcohol Vapor Displacement Drying after Wet Processing, Particles on Surfaces 2, editor K. Mittal, Plenum Press. pp. 235-43. Marra et al., Physical Principles of Marangoni Drying, Langmuir, Vol. 7, No. 11, pp. 2748-55. MARKOR DATE CONSIDERED **EXAMINER**

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Form PTO-14	•		Docket Number (Optional) 3375.6US (95-0999.4)		Application Not y t ass				
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		U.S. P.	ATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE			
HU	5,186,192	02/1993	Netsu et al.	1					
	5,328,867	07/1994	Chien et al.						
	5,520,744	05/1996	Fujikawa et al.						
	5,660,642	08/1997	Britten						
	5,681,397	10/1997	Li		<u> </u>				
	5,752,532	05/1998	Schwenkler						
	5,934,299	08/1999	Akatsu et al.						
	5,951,779	. 09/1999	Koyanagi et al.						
	5,958,146	09/1999	Mohindra et al.						
<b>A</b> .	6,125,863	10/2000	Bexten						
AM	6,138,690	10/2000	Nakatani						
		FOREIGN	PATENT DOCUMENTS						
	DOCUMENT Translation								
	NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES NO			
M	4-354128	12/1992	<b>J</b> apan	$\perp 1$	1-1				
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Sheet 1 of 1

Form PTO-1449

Docket Numb	per (Optional)
3375.6US	(95-0999.5)

Application Number 10/027,951

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M	Wong et al	., "Post-Acid Rinse Er	nhancement Through M	egasonic Quicko	dump Rinsin	o". Februarv
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